

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First

Named

Inventor: Tinghao F. Wang

Serial No.: 10/071,809

Examiner: Duy Vu Nguyen Deo

Filing

Date: February 7, 2002

Group Art Unit No. 1765

Title: METHOD FOR SELECTIVELY
 ETCHING SILICON AND/OR
 METAL SILICIDES

AMENDMENT AND REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request reconsideration in light of the following
amendments and remarks.